



AF/1762  
[10191/1728]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**



Inventors : GROSSE et al. Confirmation No.: 9967  
Serial No. : 09/831,722  
Filed : September 6, 2001  
For : DEVICE AND METHOD FOR PRODUCING A  
LOCAL PLASMA THROUGH MICROSTRUCTURE  
ELECTRODE DISCHARGES USING MICROWAVES

Examiner : E. Fuller  
Art Unit : 1762  
Customer No. : 26646

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Atty's Signature

LS Magist  
DERVIS MAGISTRE  
KENYON & KENYON

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P.O. Box 1450  
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**AMENDMENT TRANSMITTAL**

SIR:

Please find an Amendment transmitted herewith for filing in the  
above-identified patent application. Applicants respectfully request a three-month  
extension of time in which to respond to the office action dated May 31, 2005, for  
which a response period expiring on August 31, 2005 was set. The extended period  
expires on November 30, 2005.

Please charge the \$1,020.00 extension fee and any additional fees  
required to Deposit Account No. 11-0600. A duplicate copy of this Transmittal is  
enclosed.

Respectfully submitted,

KENYON & KENYON

By: LS Magist (R. No. 41,172)

Dated: 11/2/05

By: G. A. Messina

Gerard A. Messina  
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